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PTO/SB/08A (08-00)

Approved for use through 10/31/2002. OMB 0651-0031

U.S. Patent and Trademark Office: U.S. DEPARTMENT OF COMMERCE

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Substitute for form 1449A/PTO				Complete if Known	
INFORMATION DISCLOSURE STATEMENT BY APPLICANT (use as many sheets as necessary)				Application Number	08/691,434
				Filing Date	August 2, 1996
				First Named Inventor	Shunpei YAMAZAKI et al.
				Group Art Unit	2822
				Examiner Name	M. Wilczewski
Sheet	1	of	1	Attorney Docket Number	0756-1551

U.S. PATENT DOCUMENTS						
Examiner Initials ¹	Cite No. ¹	U.S. Patent Document		Name of Patentee or Applicant of Cited Document	Date of Publication of Cited Document MM-DD-YYYY	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
		Number	Kind Code ² (if known)			
MW		6,566,175		Yamazaki et al.	05/20/2003	
MW		6,482,752		Yamazaki et al.	11/19/2002	
MW		6,261,877		Yamazaki et al.	07/17/2001	
MW		6,177,302		Yamazaki et al.	01/23/2001	

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Examiner Signature	M. Wilczewski	Date Considered	7/2005
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		Number	Kind Code ³ (if known)			
TMW		5,811,327		Funai et al.	09/22/1998	

FOREIGN PATENT DOCUMENTS

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Examiner Signature	TMW Wilczewski	Date Considered	7/2005
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		Attorney Docket Number	0756-1551
Sheet 1	of 1		

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		Number	Kind Code ² (if known)			
MW		5,316,960		Watanabe et al.	05/31/1994	RECEIVED NOV 01 2004 TECH CENTER 2800

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Examiner Initials*	Cite No. ¹	Foreign Patent Document			Name of Patentee or Applicant of Cited Document	Date of Publication of Cited Document MM-DD-YYYY	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear	T ⁴
		Office ²	Number ⁴	Kind Code ³ (if known)				
MW		JP	03-042868			02/25/1991		Abst.
MW		JP	03-095965			04/22/1991		Abst.

OTHER PRIOR ART - NON PATENT LITERATURE DOCUMENTS			
Examiner Initials*	Cite No. ¹	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T ²

Examiner Signature	M. Wilczewski	Date Considered	7/2005
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GAU 2822
 Sheet 1 of 1

Form PTO-1449 (Rev. 8-83) INFORMATION DISCLOSURE STATEMENT JUL - 6 1998 (See several sheets if necessary)	U.S. Department of Commerce Patent and Trademark Office	Attorney Docket No. 0756-1551 Applicant: Shunpei YAMAZAKI et al. Filing Date: 08/02/96	Serial No. 08/691,434 Group: 1107
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Examiner Initial	Document Number	Date	Name	Class	Subclass	Filing Date (if appropriate)
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MW	4,475,027	10/02/84	PRESSLEY, Robert J.			11/17/81
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MW	64-76715	03/22/89	Japan			ABS
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MW	3-286518	12/47/91	Japan			X
MW	62-104117	05/14/87	Japan			X
MW	02-239615	09/21/90	Japan			X

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MW	Wagner et al., "Formation of p-n Junctions and Silicides in Silicon Using a High-Performance Laser Beam Homogenization System", Applied Surface Science, Vol. 43, 1989, pp. 260-263.
MW	Jhon et al., "Crystallization of Amorphous Silicon by Excimer Laser Annealing with a Line Shape Beam Having a Gaussian Profile", Jpn. J. Appl. Phys., Vol. 33, pp. L1438-L1441, Part 2, No. 10B, 15, October 1994.
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MW	Sameshima et al., "XeCl Excimer Laser Annealing Used to Fabricate Poly-Si TFT's", Japanese Journal of Applied Physics, Vol. 28, No. 10, October 1989, pp. 1789-1793.

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*EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.	

Form PTO-1449
(Rev. 8-83)

U.S. Department of Commerce
Patent, and Trademark Office

Attorney Docket No. 0756-1551

Serial No. 08/691-434

INFORMATION DISCLOSURE STATEMENT

Applicant: Shunpei YAMAZAKI et al.

Filing Date: 08/02/96

Group: 1107

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GROUP 1107

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						Yes	No
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MW	63-160336	07/04/88	Japan			ABS	
MW	03-024717	02/01/01	Japan			ABS	

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Examiner *MW Holszner*

Date Considered *6/1999*

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Form PTO-1449
(Rev. 8-83)U.S. Department of Commerce
Patent and Trademark Office

Attorney Docket No. 0756-1551

Serial No. 08/591,434

INFORMATION DISCLOSURE STATEMENT

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Applicant: Shunpei YAMAZAKI et al.

Filing Date: 08/02/96

Group: 1107

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						Yes	No
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Kuwano, Photovoltaic Behavior of Amorphous Si:H and Si:F:H Solar Cells, Conference Record, 15th IEEE Photovoltaic Specialists Conf., Kissimmee, FL, May 12-15, 1981, Published Aug. 1981, pp. 698-703.

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Date Considered

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Form PTO-1449
(Rev. 8-79)

U.S. Department of Commerce
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INFORMATION DISCLOSURE STATEMENT

(Use several sheets if necessary)

Applicant: Shunpei YAMAZAKI et al.

Filing Date: 08/02/96

Group: 1107

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<i>MW</i>	5,324,360	06/28/94	KOZUKA et al.			05/20/92
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